

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2826
Examiner: Leonardo Andujar

In Re PATENT APPLICATION OF:

Applicant : Toshinori GATO)

Appln. No. : 10/619,003)

Filed : July 15, 2003)

For : METHOD OF MANUFACTURING
A SEMICONDUCTOR DEVICE)

Attorney Ref. : OKI 278 C1)

**RESPONSE TO
ELECTION
REQUIREMENT**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Mail Stop Amendment

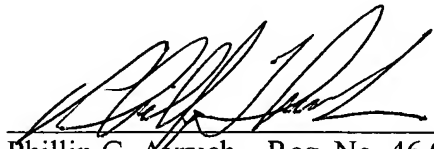
Sir:

Responsive to the Election Requirement dated December 20, 2004, Applicant elects for further examination the species of the invention represent by Embodiment 2, shown in Figure 3 of the application, which is the subject matter of claims 18-24. The election is made without traverse.

Examination of the application on the merits is respectfully requested.

Respectfully submitted,

January 21, 2005
Date


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